

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kenji SHINOZAKI

International Application No.: PCT/JP2005/003279

Application No.: NEW

Art Unit: N/A

Filed: April 24, 2006

Examiner: Not Yet Assigned

For: SUBSTRATE PROCESSING APPARATUS
AND SEMICONDUCTOR DEVICE
PRODUCING METHOD

PRELIMINARY AMENDMENT

MS PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

Amendments to the Abstract begins on page 2 of this paper.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 9 of this paper.